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By:

*Renée Conti*

Date:

*October 7, 2005*

## MAIL STOP AMENDMENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:	Patent Application of Masayuki Takashima	: Group Art Unit: 1751
		:
		:
Conf. No.:	5605	:
		:
Appln. No.	10/659,190	: Examiner: Gregory E. Webb
		:
Filed:	September 10, 2003	:
		: Attorney Docket
For:	WASHING LIQUID FOR SEMICONDUCTOR SUBSTRATE AND METHOD OF PRODUCING SEMICONDUCTOR DEVICE	: No.: 600630-8US (562653)
		:
		:

### AMENDMENT

This is in response to the Office Action dated May 31, 2005 (Paper No. 052305, hereinafter referred to as "the Office Action"), in the above-referenced application. This response is being timely filed as a petition for a two-month extension of time, up to and including October 31, 2005, including an authorization to charge fees, is being submitted herewith.

Amendments to the claims begin on page 2 of this response. Remarks begin on page of this response.

Applicant respectfully requests reconsideration by the Examiner in view of the following.